APPLICATION DATA SHEET

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Application Type:

Title of Invention:

utility

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METHOD FOR DETERMINING A PRECEDING WAFER, METHOD FOR

DETERMINING A MEASURING WAFER, AND METHOD FOR

ADJUSTING THE NUMBER OF WAFERS

Legal Representative:

Attorney or Agent:

Donald R. Studebaker

Registration Number:

32815

Continuity Data:

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Priority Claimed

Assignee (Publish): Matsushita Electric Industrial Co., Ltd.

1006, Oaza Kadoma

Kadoma-shi 571-850) Osaka JP

INVENTOR(s):

Primary Citizenship:

Japanese

Given Name:

Hiroaki

Family Name:

ISHIZUKA

Residence City:

Yawata-shi

Residence Country:

1P

Address:

4-2D19-807, Otokoyama-sasatani, Yawata-shi, Kyoto

614-8372, Japan

Yawata-shi Kyoto, 614-8372 JP

Primary Citizenship:

Japanese